



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasuhiro OMURA et al.

Group Art Unit: 2851

Application No.: 09/769,832

Examiner: R. FULLER

Filed: January 26, 2001

Docket No.: 108455

For: PROJECTION EXPOSURE APPARATUS AND METHOD, CATADIOPTIC
OPTICAL SYSTEM AND MANUFACTURING METHOD OF DEVICES

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the November 3, 2006 Office Action, the shortened statutory period for
reply being extended by the attached Petition for Extension of Time, please consider the
following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.